IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazuto HIROKAWA et al.

Attn: APPLICATION BRANCH

Serial No. NEW

Attorney Docket No. 2003-0961A

Filed July 14, 2003

SUBSTRATE POLISHING APPARATUS

COVER LETTER ACCOMPANYING APPLICATION FILED WITHOUT EXECUTED DECLARATION UNDER 37 CFR 1.53(b) AND IN A LANGUAGE OTHER THAN ENGLISH UNDER 37 CFR 1.52(d)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a new patent application entitled "SUBSTRATE POLISHING APPARATUS". This application is submitted in the Japanese language under the provisions of 37 CFR 1.52(d).

Furthermore, the present application is submitted under the provisions of 37 CFR 1.53(b), and the application as filed does not include an executed declaration. However, accompanying the application is an unexecuted declaration listing the inventor information.

The application as filed further does not include an executed power of attorney, and accordingly, it is requested that communication initially be directed to the following firm, until an executed power of attorney and declaration are filed:

WENDEROTH, LIND & PONACK, L.L.P. 2033 K Street, N.W., Suite 800 Washington, D.C. 20006-1021

Telephone: (202) 721-8200 Facsimile: (202) 721-8250 The required filing fee of \$750.00 is enclosed.

Respectfully submitted,

Kazuto HIROKAWA et al.

By

Nils E. Pedersen

Registration No. 33,145 Attorney for Applicants

NEP/krl Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 July 14, 2003

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

DECLARATION AND POWER OF ATTORNEY FOR U.S. PATENT APPLICATION

(X) Original () Supplemental () Substitute () PCT () DESIGN

As a below named inventor, I hereby declare that: my residence, post office address and citizenship are as stated below next to my name; that I verily believe that I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

Title: SUBSTRATE POLISHING APPARATUS

of which is described and claimed in:			
(X) the attached specification, or			
() the specification in application Serial No.	, filed	, and with amendments through	OI
() the specification in International Application No.	, filed, and as amended on	(if applicable).	_, 01

I hereby state that I have reviewed and understand the content of the above-identified specification, including the claims, as amended by any amendment(s) referred to above.

I acknowledge my duty to disclose to the Patent and Trademark Office all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, §1.56.

I hereby claim priority benefits under Title 35, United States Code, §119 (and §172 if this application is for a Design) of any application(s) for patent or inventor's certificate listed below and have also identified below any application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

COUNTRY	APPLICATION NO.	DATE OF FILING	PRIORITY CLAIMED
Japan	2003-138479	May 16, 2003	YES
Japan	2003-138496	May 16, 2003	YES
Japan	2003-138782	May 16, 2003	YES

I hereby claim the benefit under Title 35, United States Code §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code §112, I acknowledge the duty to disclose information material to patentability as defined in Title 37, Code of Federal Regulations, §1.56 which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

APPLICATION SERIAL NO.	U.S. FILING DATE	STATUS: PATENTED, PENDING, ABANDONED

And I hereby appoint Michael R. Davis, Reg. No. 25,134; Matthew M. Jacob, Reg. No. 25,154; Warren M. Cheek, Jr., Reg. No. 33,367; Nils Pedersen, Reg. No. 33,145; Charles R. Watts, Reg. No. 33,142; Michael S. Huppert, Reg. No. 40,268; and Jeffrey R. Filipek, Reg. No. 41,471, who together constitute the firm of WENDEROTH, LIND & PONACK, L.L.P., as well as any other attorneys and agents associated with Customer No. 000513, to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected therewith.

I hereby authorize the U.S. attorneys and agents named herein to accept and follow instructions from <u>WATANABE & HOTTA</u> as to any action to be taken in the U.S. Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and myself. In the event of a change in the persons from whom instructions may be taken, the U.S. attorneys named herein will be so notified by me.

Direct Correspondence to Customer No: Direct Telephone Calls to: WENDEROTH, LIND & PONACK, L.L.P. 2033 "K" Street, N.W., Suite 800 Washington, D.C. 20006-1021 000513 Phone: (202) 721-8200 Fax:(202) 721-8250 PATENT TRADEMARK OFFICE **FAMILY NAME** FIRST GIVEN NAME **Full Name of** SECOND GIVEN NAME **HIROKAWA** Kazuto First Inventor **CITY** STATE OR COUNTRY Residence & COUNTRY OF CITIZENSHIP Tokyo Japan Citizenship Japan. **ADDRESS** CITY STATE OR COUNTRY **Post Office** ZIP CODE c/o Ebara Corporation, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo, Japan **Address FAMILY NAME** FIRST GIVEN NAME Full Name of SECOND GIVEN NAME **NAKAI** Shunsuke **Second Inventor** CITY STATE OR COUNTRY Residence & **COUNTRY OF CITIZENSHIP** Tokyo Japan Citizenship Japan **ADDRESS Post Office** CITY STATE OR COUNTRY ZIP CODE c/o Ebara Corporation, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo, Japan **Address Full Name of FAMILY NAME** FIRST GIVEN NAME SECOND GIVEN NAME **OHTA** Shinro **Third Inventor** CITY STATE OR COUNTRY Residence & **COUNTRY OF CITIZENSHIP** Tokyo Citizenship Japan Japan ADDRESS **Post Office** STATE OR COUNTRY ZIP CODE c/o Ebara Corporation, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo, Japan Address **FAMILY NAME** FIRST GIVEN NAME **Full Name of** SECOND GIVEN NAME WADA Yutaka **Fourth Inventor** CITY STATE OR COUNTRY Residence & COUNTRY OF CITIZENSHIP Tokyo Citizenship Japan Japan **ADDRESS** CITY **Post Office** STATE OR COUNTRY ZIP CODE c/o Ebara Corporation, 11-1, Haneda Asahi-cho, Ohta-ku, Tokyo, Japan Address **FAMILY NAME** FIRST GIVEN NAME **Full Name of** SECOND GIVEN NAME **KOBAYASHI** Yoichi Fifth Inventor CITY STATE OR COUNTRY Residence & COUNTRY OF CITIZENSHIP Tokyo Japan Citizenship Japan

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Residence & Citizenship	СІТУ	STATE OR COUNTRY	COUNTRY OF CITIZENSHIP
Post Office Address	ADDRESS	CITY	STATE OR COUNTRY ZIP CODE

I further declare that all statements made herein of my own knowledge are true, and that all statements on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Ist Inventor Date Kazuto HIROKAWA 2nd Inventor Date Shunsuke NAKAI 3rd Inventor Date Shinro OHTA 4th Inventor Date Yutaka WADA
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Shinro OHTA 4th Inventor Date
Shinro OHTA 4th Inventor Date
4th Inventor Date Date
Yutaka WADA
5th Inventor Date
Yoichi KOBAYASHI
6th Inventor Date

The above application may be more particularly identified as follows:

U.S. Application Serial No. NEW Filing Date July 14, 2003

Applicant Reference Number GEB1956-US Atty Docket No. 2003-0961A

Title of Invention SUBSTRATE POLISHING APPARATUS